

Notice of References Cited

Application/Control No.

09/810,828

Applicant(s)/Patent Under

Reexamination

ZARRABIAN ET AL.

Examiner

Thomas R Artman

Art Unit

2882

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	NOT AVAILABLE COPY	Classification
	A	US-5,343,542	08-1994	Kash et al.		356/454
	B	US-5,144,498	09-1992	Vincent, Kent D.		250/226
	C	US-				
	D	US-				
	E	US-				
	F	US-				
	G	US-				
	H	US-				
	I	US-				
	J	US-				
	K	US-				
	L	US-				
	M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Takashashi, Haruo. "Temperature stability of thin-film narrow-bandpass filters produced by ion-assisted deposition." <input type="checkbox"/> Applied Optics, Vol. 34, No. 4, Feb.1, 1995, pp.667-675
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.